

Symposium (Oral) | Symposium | Trends and Prospects of MEMS and Microfabrication Technologies Contributing to the With-Covid-19 Era

[17p-E502-1~9]Trends and Prospects of MEMS and Microfabrication Technologies Contributing to the With-Covid-19 Era

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Fri. Mar 17, 2023 1:30 PM - 5:00 PM E502 (Building No. 12)

△ : Presentation by Applicant for JSAP Young Scientists Presentation Award

▲ : English Presentation

▼ : Both of Above

No Mark : None of Above

3:05 PM - 3:15 PM

[17p-E502-5]Awards Ceremony

○Seiichi Hata¹ (1.Nagoya University)

Keywords: Integrated MEMS